

FIG. 1A

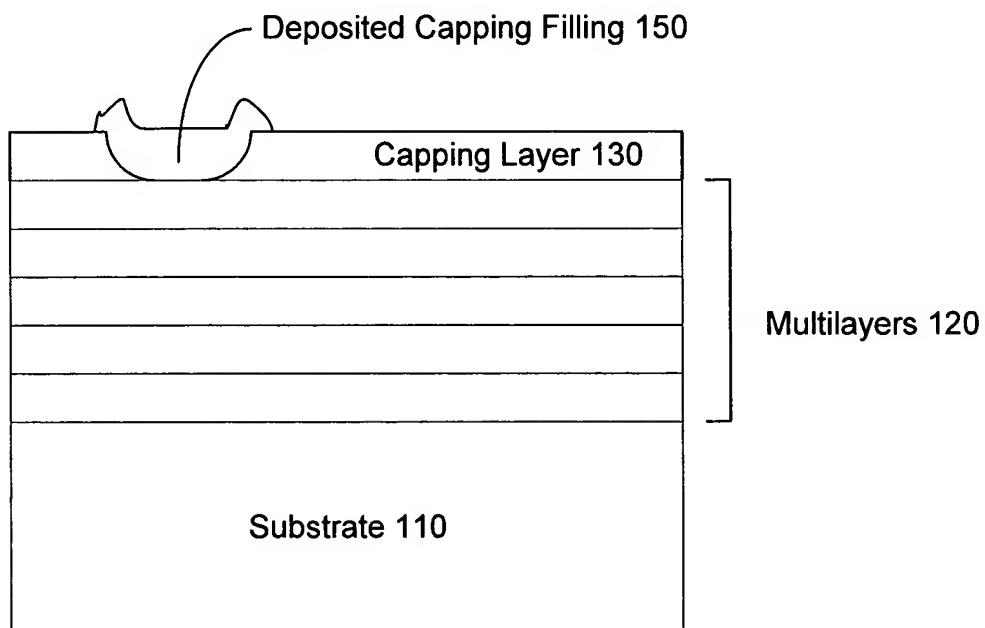


FIG. 1B

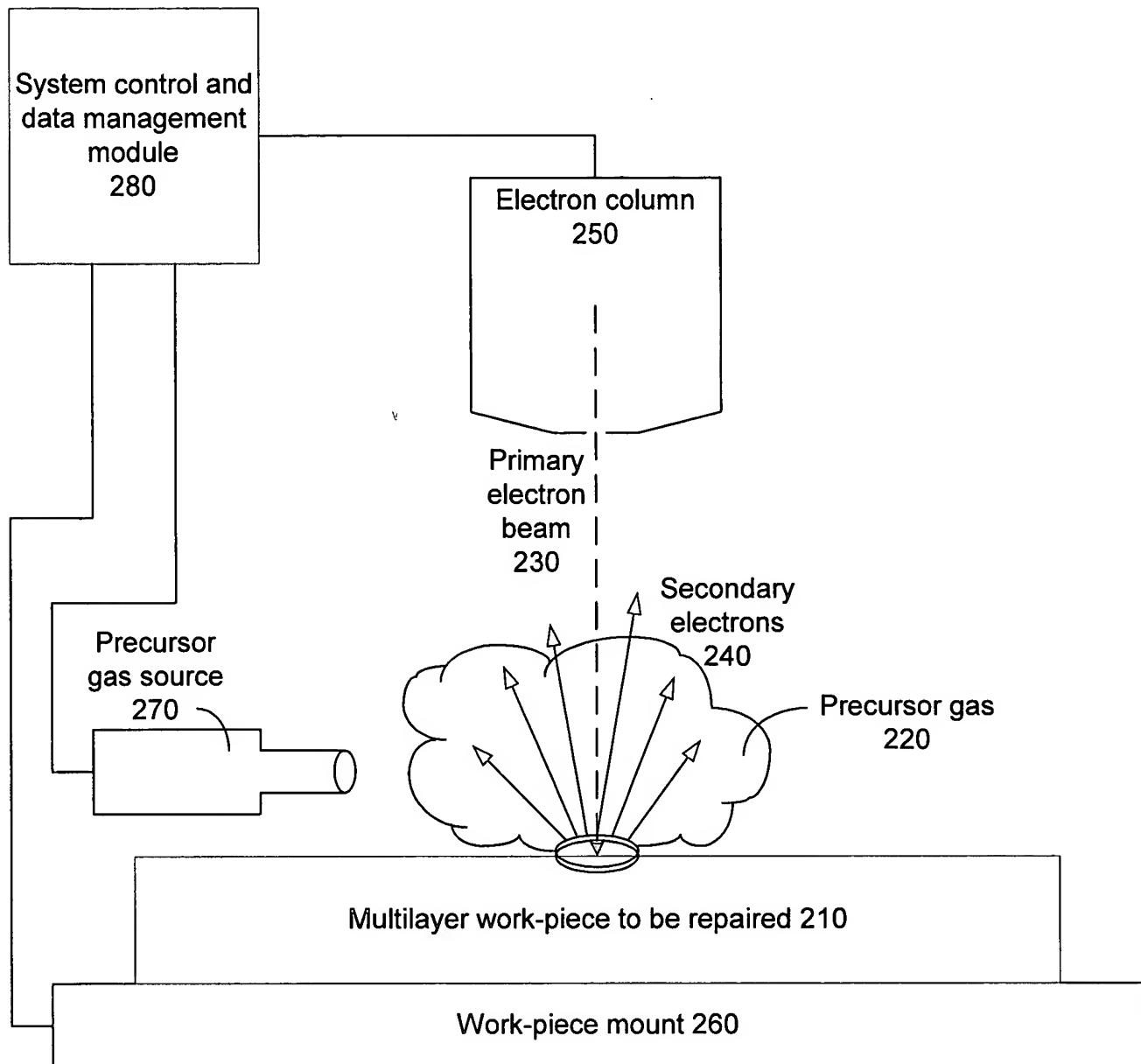


FIG. 2

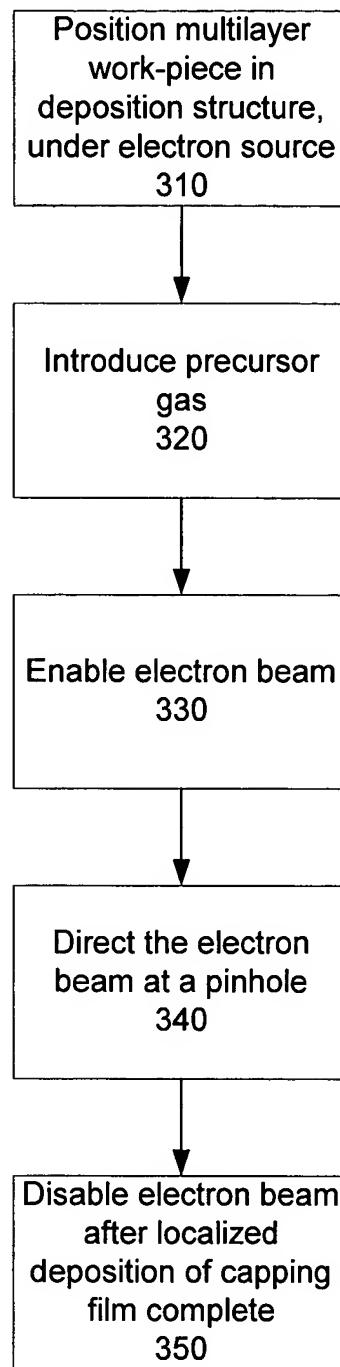


FIG. 3

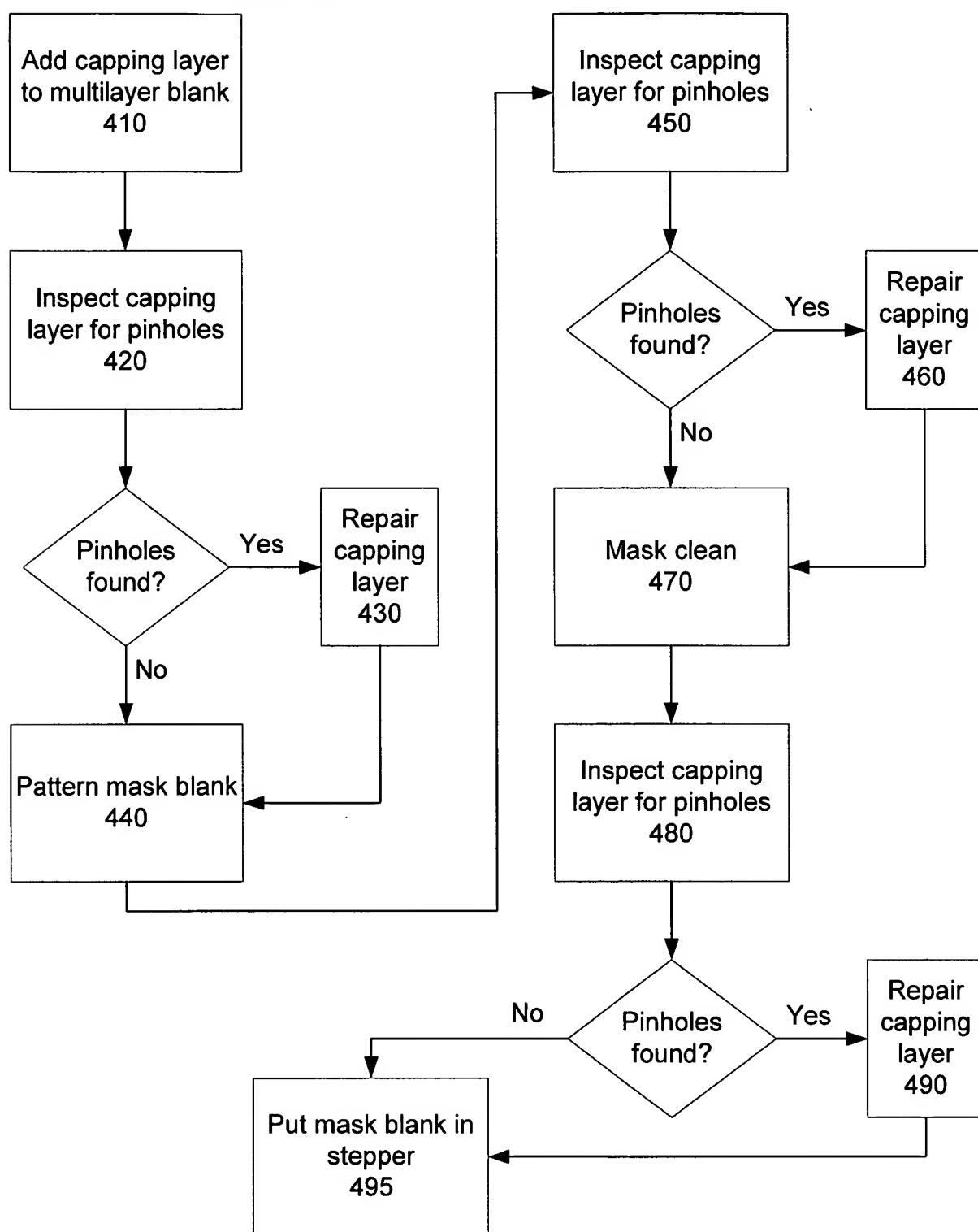


FIG. 4

Capping layer material 510	Precursor gas 520
Silicon	SiH_4 , Si_2H_6
Ruthenium	RuF_6 , $\text{Ru}(\text{CO})_5$, $\text{Ru}_3(\text{CO})_{12}$
Carbon	CH_4

FIG. 5